Surface plasmon polariton modes in a single-crystal Au nanoresonator fabricated using focused-ion-beam milling

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We use focused-ion-beam milling of a single-crystal Au surface to fabricate a 590-nm-long linear ridge that acts as a surface plasmon nanoresonator. Cathodoluminescence imaging spectroscopy is then used to excite and image surface plasmons on the ridge. Principal component analysis reveals distinct plasmonic modes, which proves confinement of surface plasmon oscillations to the ridge. Boundary-element-method calculations confirm that a linear ridge is able to support highly localized surface plasmon modes (mode diameter <100 nm). The results demonstrate that focused-ion-beam milling can be used in rapid prototyping of nanoscale single-crystal plasmonic components. © 2008 American Institute of Physics. [DOI: 10.1063/1.2885344]

Surface plasmon polaritons (SPPs) are electromagnetic waves confined to a metal-dielectric interface. As shown in recent experiments, SPPs can be manipulated using waveguides and resonators. Surface plasmon polaritons hold promise for application in sensing, photovoltaics, telecommunications, and optoelectronic circuit integration due to their ability to concentrate and guide electromagnetic energy at the nanoscale.

Fabrication of components that guide and confine SPPs involves structuring of metals, typically using methods such as electron beam lithography, nanoimprint lithography, self-assembly, or templating techniques. These methods offer high spatial resolution, but require complex multistep processing. Moreover, the metal films, most often obtained by thermal evaporation, typically have a polycrystalline structure. Grain boundaries and surface roughness in polycrystalline films are known to cause undesired scattering of SPPs.

A single-step method to structure metals for plasmonic applications, that is gaining widespread acceptance, is focused-ion-beam (FIB) milling. In a typical FIB system, Ga+ ions are extracted from a liquid-metal ion source, accelerated to 30 keV, and focused by an electrostatic lens system to a spot size with diameter as small as 5–10 nm.

In this letter, we show how FIB milling of a single-crystal Au substrate can be used for highly reproducible, maskless fabrication of a smooth plasmonic resonator, with minimum lateral dimension of 50 nm, and surface roughness on the scale of only a few nanometers. We use cathodoluminescence (CL) imaging spectroscopy to generate SPPs (Refs. 7 and 8) and image resonant modes within the metal nanostructures. The data demonstrate that FIB is an ideal tool for fabrication of nanoscale plasmonic components, in particular, when single-crystal metal substrates are employed. Our conclusions are supported by boundary-element-method (BEM) calculations of the local fields at the metal nanostructures.

Nanoplasmonic device fabrication consisted of focused-ion-beam milling a polished (111) single-crystal Au substrate, grown using the Czochralski process. A 10 pA, 30 keV Ga beam from a FEI Nova 600 dual-beam workstation was rastered in 40 passes over a 4 × 5 μm² area, using a 1000 × 1250 pixel grid using a variable dwell time per pixel. Subtractive milling left behind a linear ridge, approximately 590 nm long, 95 nm high, and 80 nm wide. Fabrication of such a ridge takes roughly 1 min and is very reproducible. Resulting ridge roughness is on the order of a few nanometers.

Figure 1 shows scanning electron microscope (SEM) images of the ridge, taken at large azimuthal angle with respect to the normal. Views of the structure at two different polar angles are presented, respectively, several degrees off (a) and along (b) the ridge axis. The images reveal rounded features at the top of the ridge and at the base. We attribute this rounding to redeposition of Au during milling as well as the finite diameter of the ion beam (~10 nm). The features visible in the milled area around the ridge are attributed to

FIG. 1. (Color online) (a) Scanning electron micrograph of a 590-nm-long linear ridge fabricated in a single-crystal Au substrate using focused-ion-beam milling. The ridge is approximately 95 nm high and 80 nm wide. (b) The same ridge from a different angle. (c) Boundary-element-method calculation of the field intensity |E|² near an infinitely long bell-shaped Au ridge. This calculation, performed at a photon energy 2.13 eV and kF = 1.14\omega/c, shows that propagating surface plasmons at this energy are well confined to the top of the ridge and do not couple to the planar-surface plasmons, for which kF = 1.07\omega/c.
extract the principal modes from the data in Fig. 2. Each consecutive profile is shifted by one intensity unit for clarity. Numbers labeling each profile correspond to respective spectra of Fig. 2(d). Profiles 3 and 4 show resonant modes of the ridge with one and two antinodes on the ridge, respectively.

As previously shown, spatial CL images are a direct probe of resonant modes of plasmonic nanostructures. The measured CL spectrum at any position is assumed to be a linear superposition of multiple principal-mode spectra. We extract the principal modes from the data in Fig. 2(b) using a factor analysis method, that involves solving an eigenvalue problem: a two-dimensional data matrix \( D_{x,\lambda} \) is defined, with one spectral and one spatial dimensions, corresponding to the dimensions of Fig. 2(b), respectively, as a product of two matrices \( D_{x,\lambda} = R_{x,n} C_{n,\lambda} \), one having \( n \) spatial profiles as columns and the other having the corresponding \( n \) spectra as rows. We find that five principal components, found using a “scree plot” of the logarithms of the eigenvalues versus component number, form a good representation of the data, so that matrices \( R \) and \( C \) with \( n=5 \) can be used to construct the full data set.

We then impose on the mode spectra a Lorentzian shape, parametrized by a peak wavelength and a characteristic width for every spectrum; an initial matrix \( C \) is composed of five spectra. The profile matrix \( R \) can then be computed by the pseudoinverse of \( C: R = DC^\ast \), for which a data set \( \hat{D} = RC \) is then calculated. The parameters for the spectra matrix \( C \) are then optimized using a least-squares method by minimizing the difference between the original data set \( D \) and the generated \( \hat{D} \). Figure 2(c) shows the obtained \( \hat{D} \). The result is in excellent agreement with the data, reproducing the spectral shape and intensity at all positions on the ridge. The resulting five spectra from \( C \) are plotted in Fig. 2(d). The peak wavelengths in Fig. 2(d) range from 425–797 nm. The cavity \( Q \) factor, obtained from the width of spectrum 3 is \( Q=5.3 \).

Figure 3 displays the spatial profiles of the five spectra along the ridge, as given by \( R \). Spatial profiles for spectra 3 and 4 are characteristic of resonant modes, with one and two antinodes on the ridge, respectively. The spatial profiles for spectra 1 and 2, at longer wavelengths, show antinodes on the ridge ends. The spatial profile for spectrum 5 shows a relatively constant intensity along the ridge; it may be associated with a higher order mode of which the spatial profile cannot be resolved, or transition radiation that does not have spatial dependence. Note that spectra 2 and 3, which are close together spectrally, have very distinct spatial profiles.

This analysis demonstrates the existence of geometrical plasmon modes along the single-crystal Au ridge that are preferentially excited at antinodes in the modal electric field intensity. A BEM was used to calculate plasmon modes of a geometry similar to that of the experimental structure. Starting from a shape profile as input, the electric field is expressed in terms of charge and current distribution on the...
ridge, which are calculated self-consistently to fulfill the field boundary conditions. We choose a bell-shaped linear ridge of infinite length characterized by two different radii of curvature, as shown by the grey curve in Fig. 1(c). The shape is similar to that of the ridge imaged in Fig. 1(b). We first calculated the photonic local density of states (LDOS) in the dielectric just above the top of the ridge [indicated in Fig. 1(c) by the black cross]. This was done for a range of energies, separating the LDOS into contributions arising from different spatial frequencies \( k_{1} \) along the ridge.

For example, at an energy of 2.13 eV [corresponding to a free space wavelength of 582 nm and peak 3 in Fig. 2(d)], we find a LDOS maximum for \( k_{1} = 1.14 \omega / c \). This is significantly larger than the corresponding value \( k_{1} = 1.07 \omega / c \) calculated for SPPs on a planar Au surface (using identical optical constants), consistent with strong mode confinement to the ridge. Indeed, the figure shows that the intensity is very much confined to the top of the ridge, with a typical lateral confinement in the y direction well below 100 nm. From the BEM calculation, the plasmon propagation length along an infinitely long ridge is \( 4 \mu \text{m} \) (\( Q = 43 \)). This implies that the measured value \( Q = 5.3 \) is due to the combined effect of Ohmic losses (possibly enhanced by the presence of implanted Ga from the FIB process) and radiation losses from the ridge ends.

In summary, we have shown that using focused-ion-beam milling, a smooth linear ridge that supports surface plasmon resonances can be fabricated on a single-crystal Au substrate. Spatially resolved cathodoluminescence spectroscopy shows that surface plasmons generated on this ridge are well confined to the ridge and form distinct geometrical modes. The data are confirmed by BEM calculations of the plasmon field distribution on the ridge, which show that a propagating surface plasmon is confined to the top of the ridge, with a mode diameter <100 nm. These results show that FIB milling of a single-crystal noble metal surface can be used in rapid prototyping of nanoscale surface plasmon components.

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